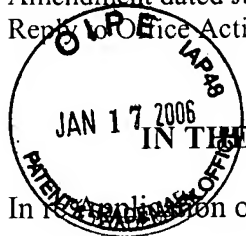


Application No. 10/822,343
Amendment dated January 13, 2006
Reply to Office Action dated November 30, 2005

Attorney Docket No. 124263-1020



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Reply, please mention of: Meng Tao

Application No.: 10/822,343

Filing Date: April 12, 2004


Art Unit: 2813

Examiner: Thanhha S. Pham

For: SUPPRESION OF CHEMICAL REACTIVITY ON
SEMICONDUCTOR SURFACES

Certificate of Mailing under 37 CFR 1.8

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope, with sufficient postage, addressed to: MAIL STOP AMENDMENT, Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450, on January 13, 2006.



Signature

MAIL STOP AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria VA 22313-1450

Stella E. Laicer

Typed or printed name of person signing certificate

AMENDMENT

Dear Sir:

Applicants submit this response to the non-final Office Action mailed on the date of November 30, 2005. In view of the following Remarks/Arguments, Applicants respectfully request reconsideration and withdrawal of the restriction requirement, and allowance of the claims pending in this application.

In response to the Office Action, please reconsider the above-identified application in light of the following:

Amendments to the Claims provided in the Listing of Claims that begins on page two (2) of this paper; and

Remarks/Arguments that begin on page six (6) of this paper.